



**PATENT**  
Attorney Docket No.: SSI-04001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

William Dale Jones

Serial No.: 10/680,783

Filed: October 6, 2003

For: **HIGH-PRESSURE PROCESSING  
CHAMBER FOR A  
SEMICONDUCTOR WAFER**

) Group Art Unit: 1763  
) Examiner: Lund, Jeffrie Robert  
) Response to the final Office Action mailed  
) on January 30, 2006  
) 162 N. Wolfe Road  
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with fee  
4-25-06  
JPC*  
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Applicant submits this response to the final Office Action mailed on January 30, 2006:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.